

Application of a 10nm particle counter and non-volatile residue monitor for component diagnostics within a UPW system

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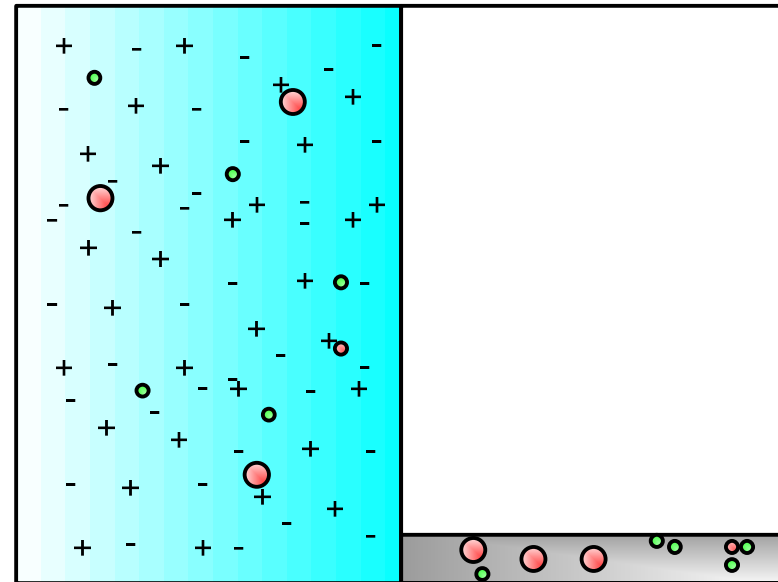
Outline

- Non-Volatile Residue in Liquids – What is it and how do we characterize it?
- Aerosolization – What does it mean and what factors drive performance?
- Overview of instrumentation
 - Non-Volatile Residue Monitor
 - Scanning Threshold Particle Counter
- System sampling data

Non-Volatile Residue

Definition

- Non-Volatile Residue (NVR) refers to solid material remaining after evaporation of a liquid
- Composed of previously dissolved salts, organics, and solid particles that were present in the liquid (colloidal particles)



Liquid Sample
With NVR

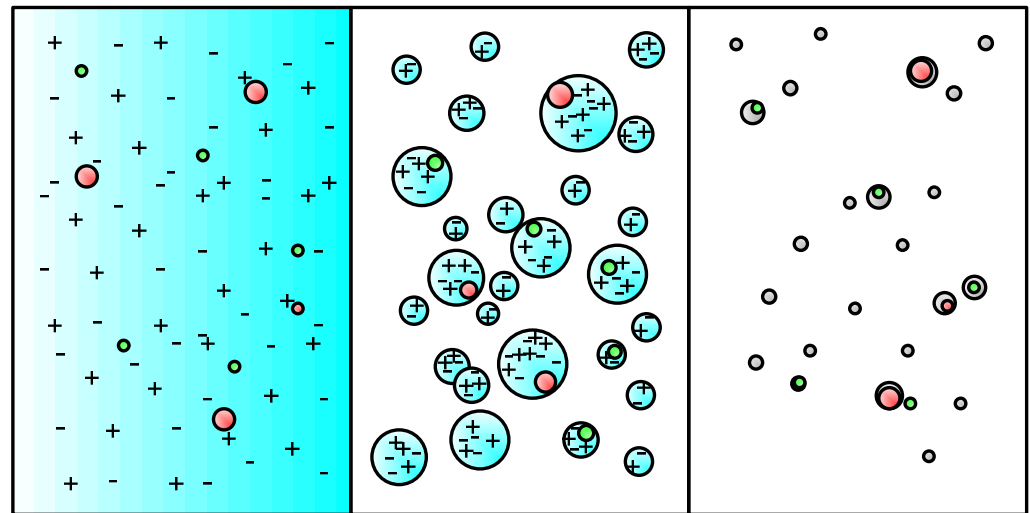
Evaporated
Sample

- Insoluble Suspended Particles
- Semi-volatile Organics
- ⊕ Dissolved Non-Volatile Residue
- Precipitated Non-Volatile Residue

Aerosolization

Definition

- Spray liquid to form a mist of fine droplets (Nebulization)
- Evaporate liquid from the droplets
- Each droplet forms a solid aerosol particle composed of Precipitated Non-Volatile Residue (PNVR) whose size is proportional to the original droplet size
- A small fraction of the aerosol particles will also contain insoluble suspended particles and/or semi-volatile organics found in the original sample



Liquid Sample
With NVR

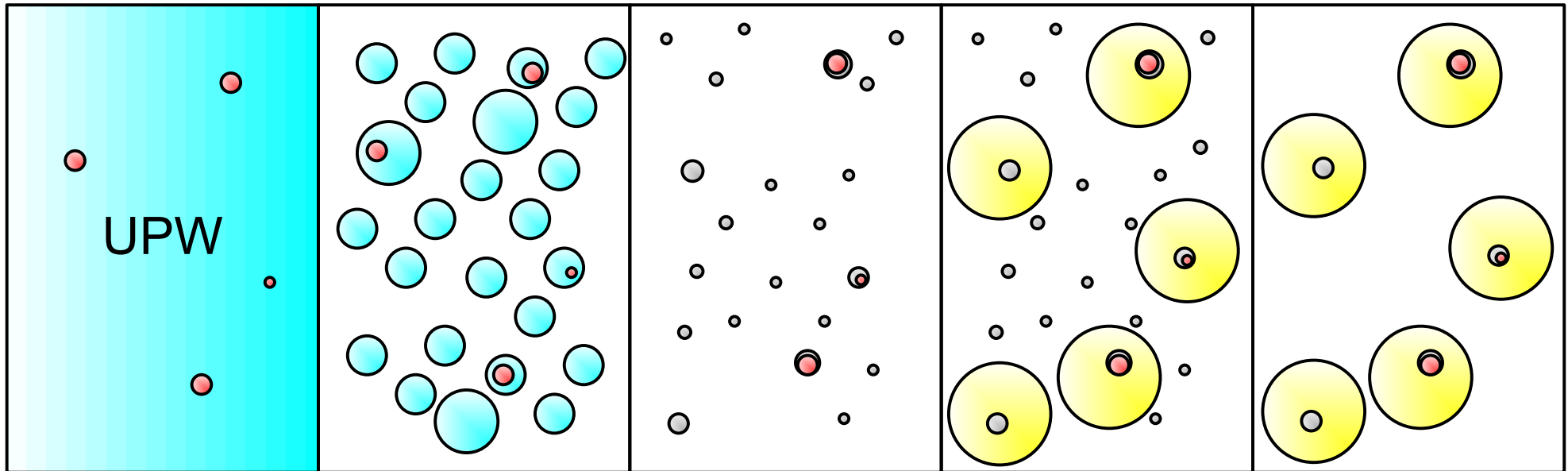
Nebulized
Sample

Aerosolized
Sample

- Insoluble Suspended Particles
- Semi-volatile Organics
- ⊕ Dissolved Non-Volatile Residue
- Precipitated Non-Volatile Residue

Non-Volatile Residue Monitor (NRM)

Principle of Operation



Sample
containing
NVR

Nebulization

Evaporation

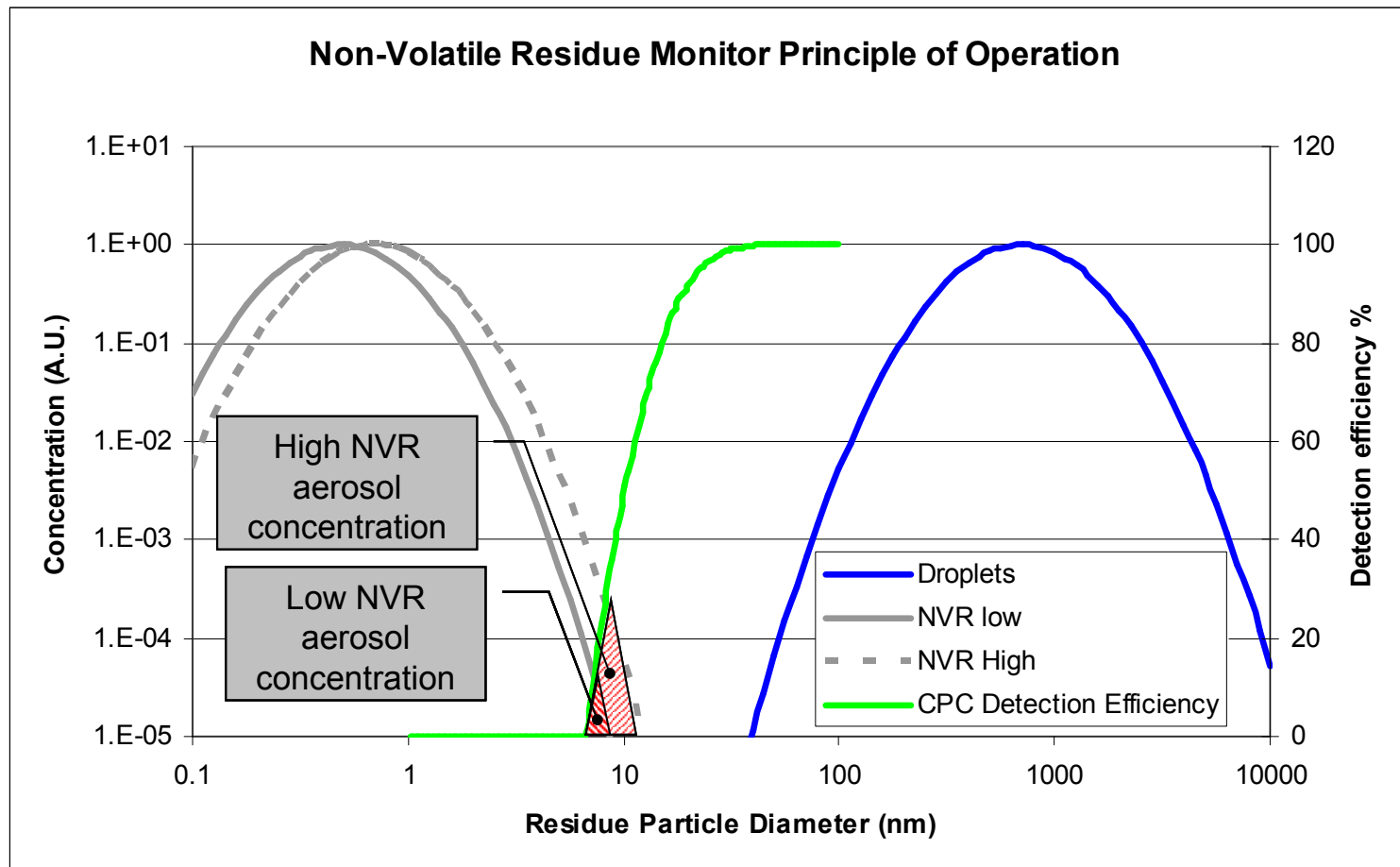
Size Selective
Condensation
Growth

Optical
Detection

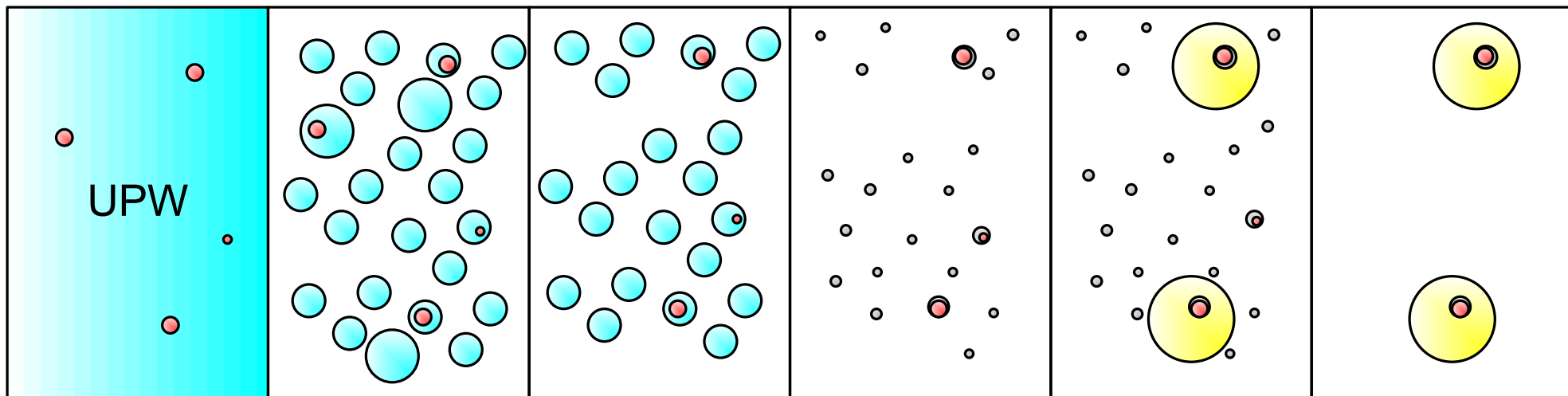
Condensation Particle Counter

Non-Volatile Residue Monitor

- Condensation Particle Counter (CPC) detects more particles with increasing NVR concentration



Scanning Threshold Particle Counter (Scanning TPC)



Nebulization

Large Droplet
Removal

Evaporation

Size Selective
Condensation
Growth

Optical
Detection

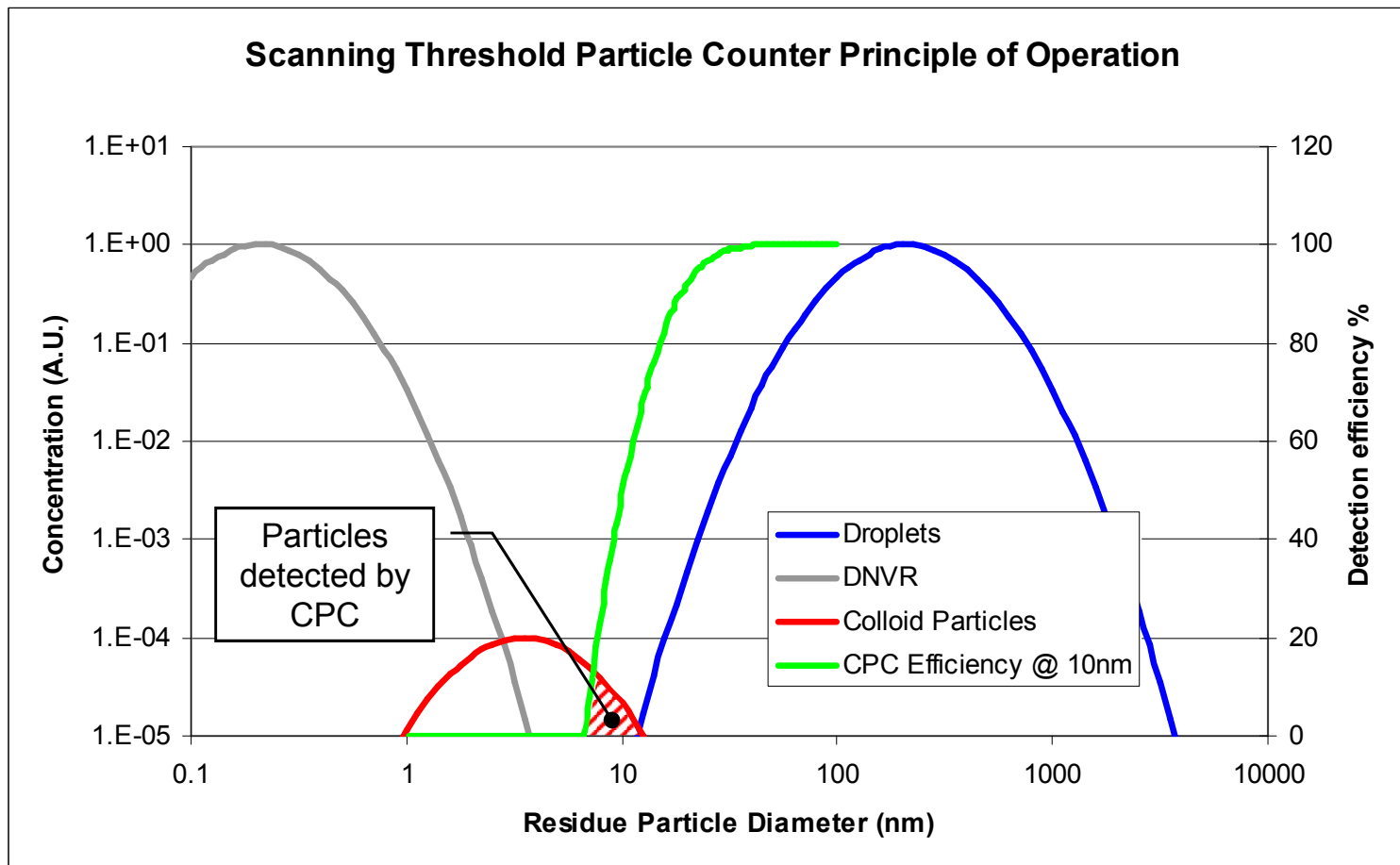
Limits large
PNVR particles
otherwise
detected by the
NRM

Only counts aerosol
particles that contain
insoluble liquid borne
particles

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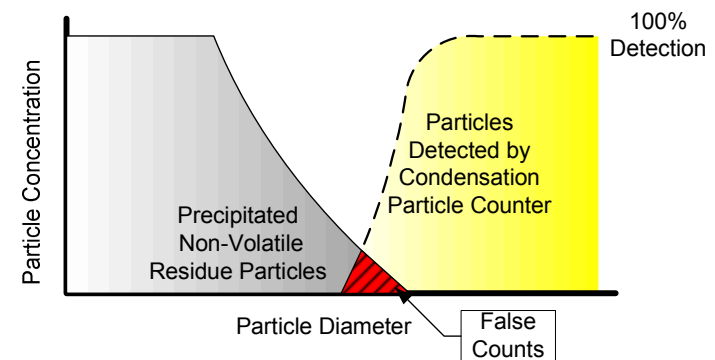
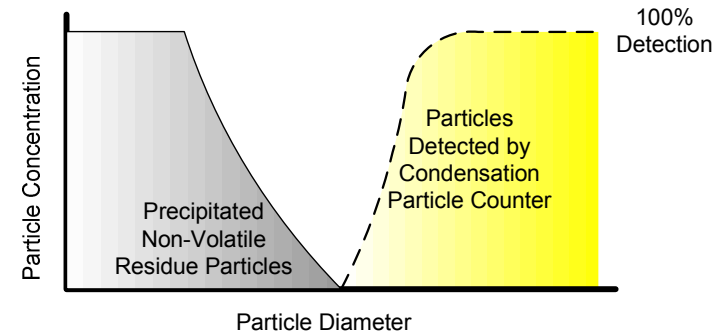
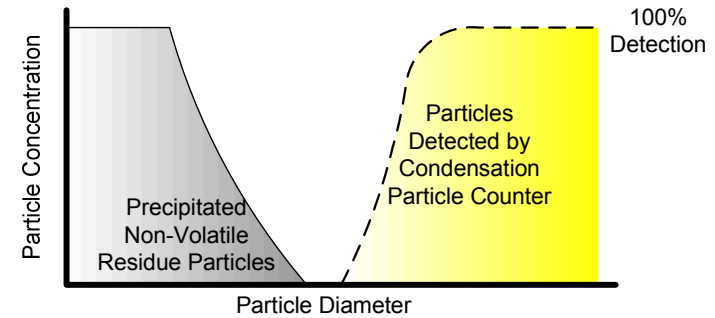
Scanning Threshold Particle Counter (ScanningTPC)

- Nebulizer produces droplets that form DNVR particles smaller than smallest size detected by CPC



Scanning Threshold Particle Counter (ScanningTPC)

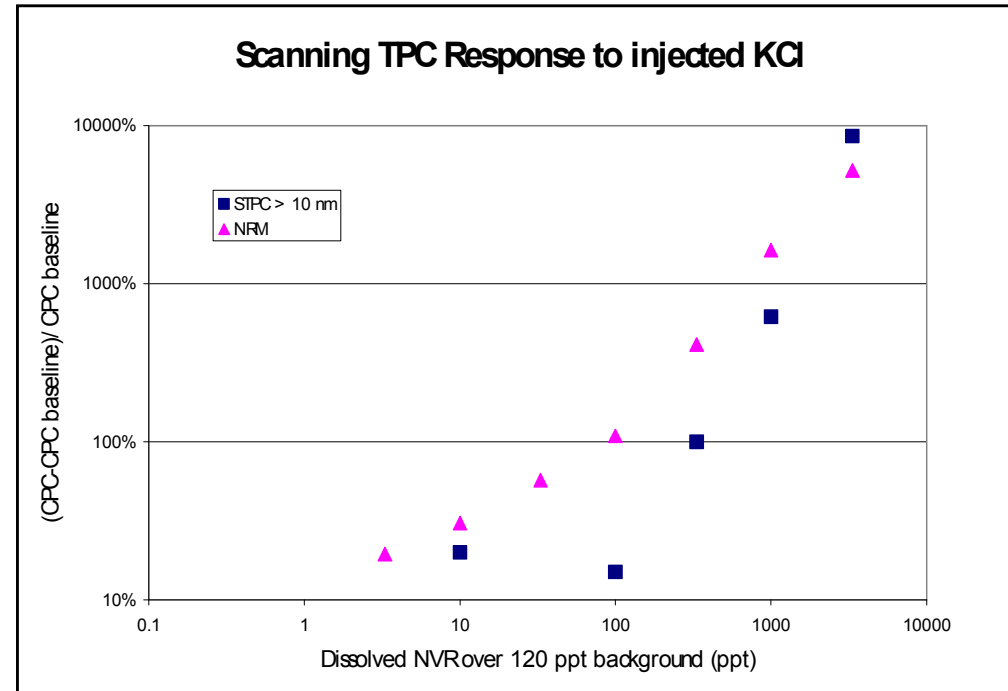
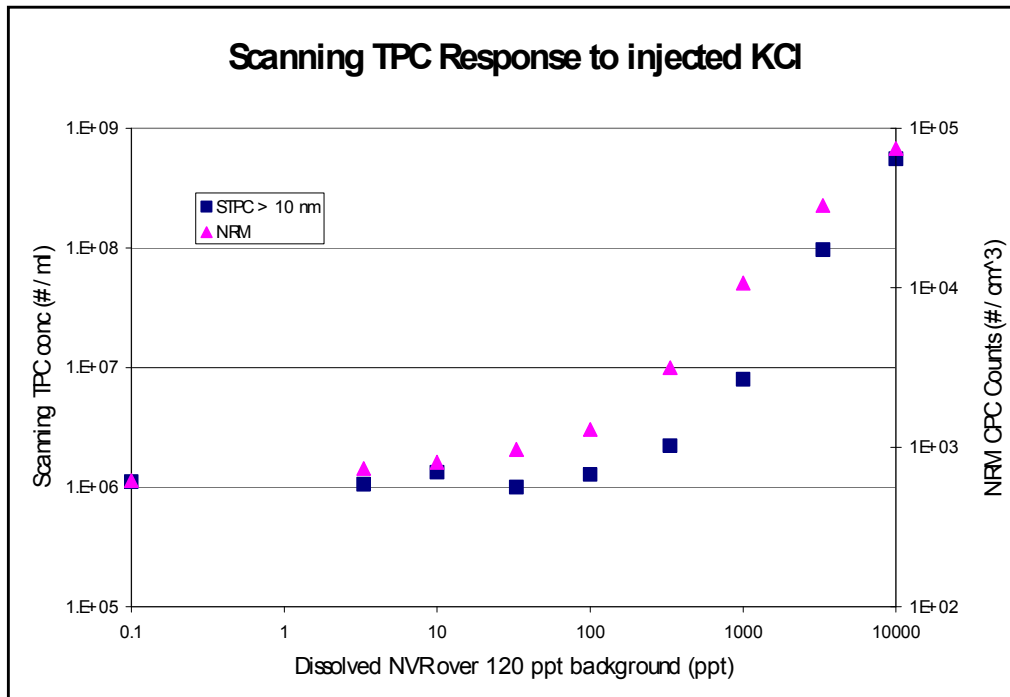
- False counts
 - CPC noise
 - Large droplets forming large precipitated residue particles
 - Coagulation of aerosol particles
 - Coincident particles within a droplet
- Total NVR ideally monitored in parallel



Scanning Threshold Particle Counter (ScanningTPC)

Dissolved Non-Volatile Residue Interference

- ScanningTPC does not show response when injected with low levels of DNVR

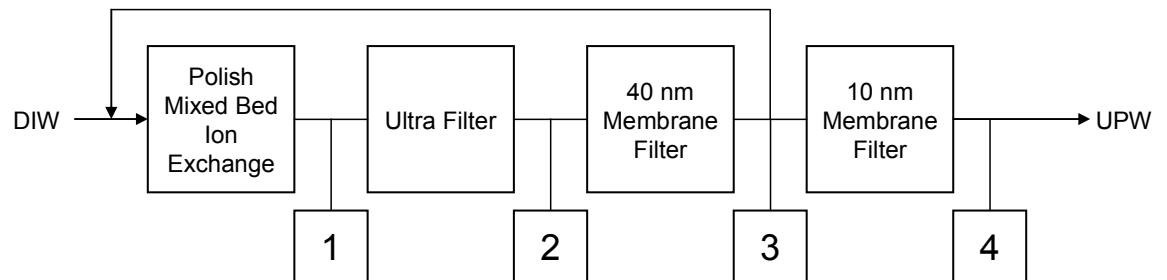
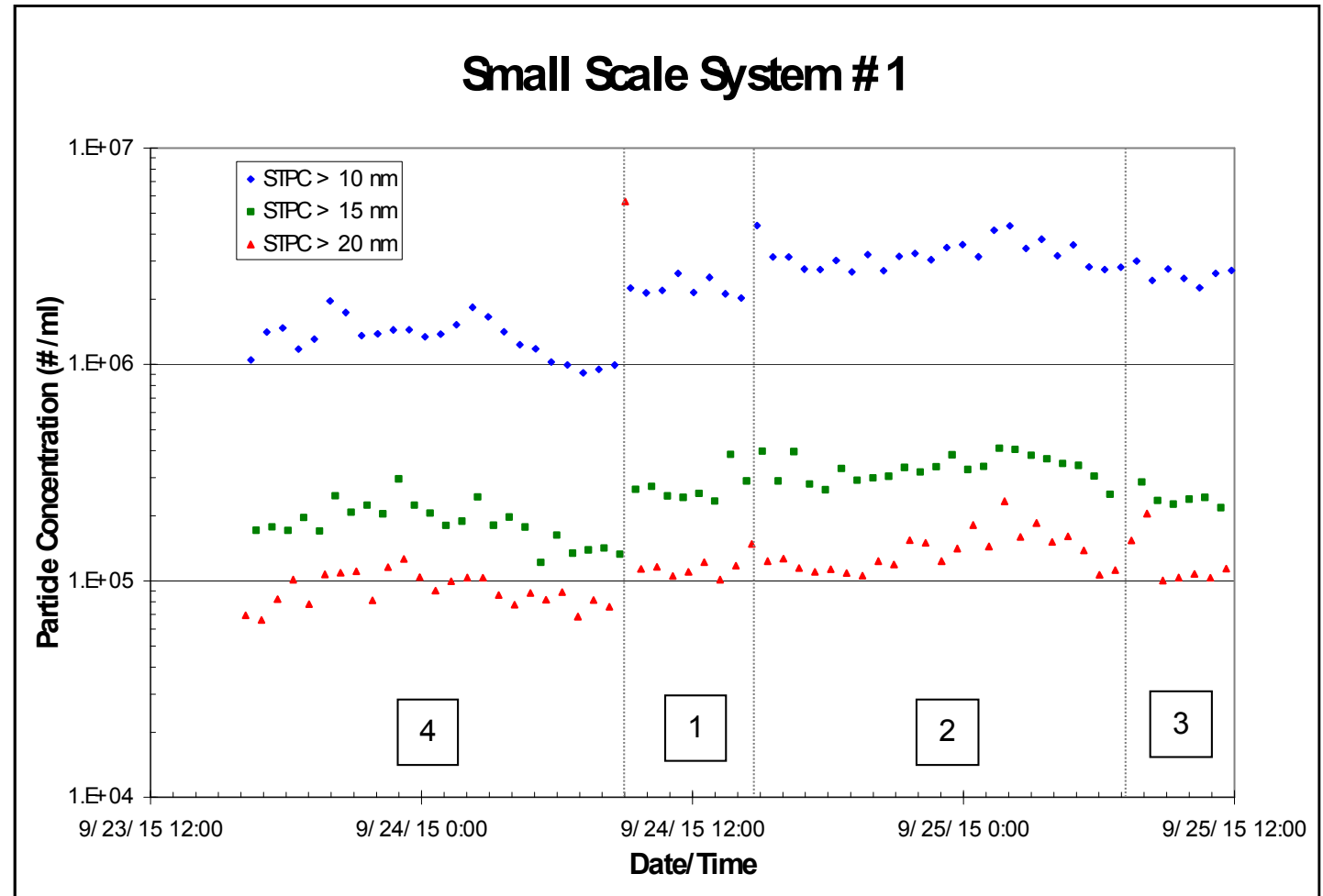


- ScanningTPC response is combination of insoluble particles in the challenge solution and precipitated NVR larger than the threshold diameter
- A portion of the response is likely due to particles in the KCl solution

Scanning TPC Monitoring

Small Water System 1

- UF shows slight increase in particle counts, likely due to dirty sampling port
- High performance membrane filter shows reduction of particles at all sizes



What did we learn?

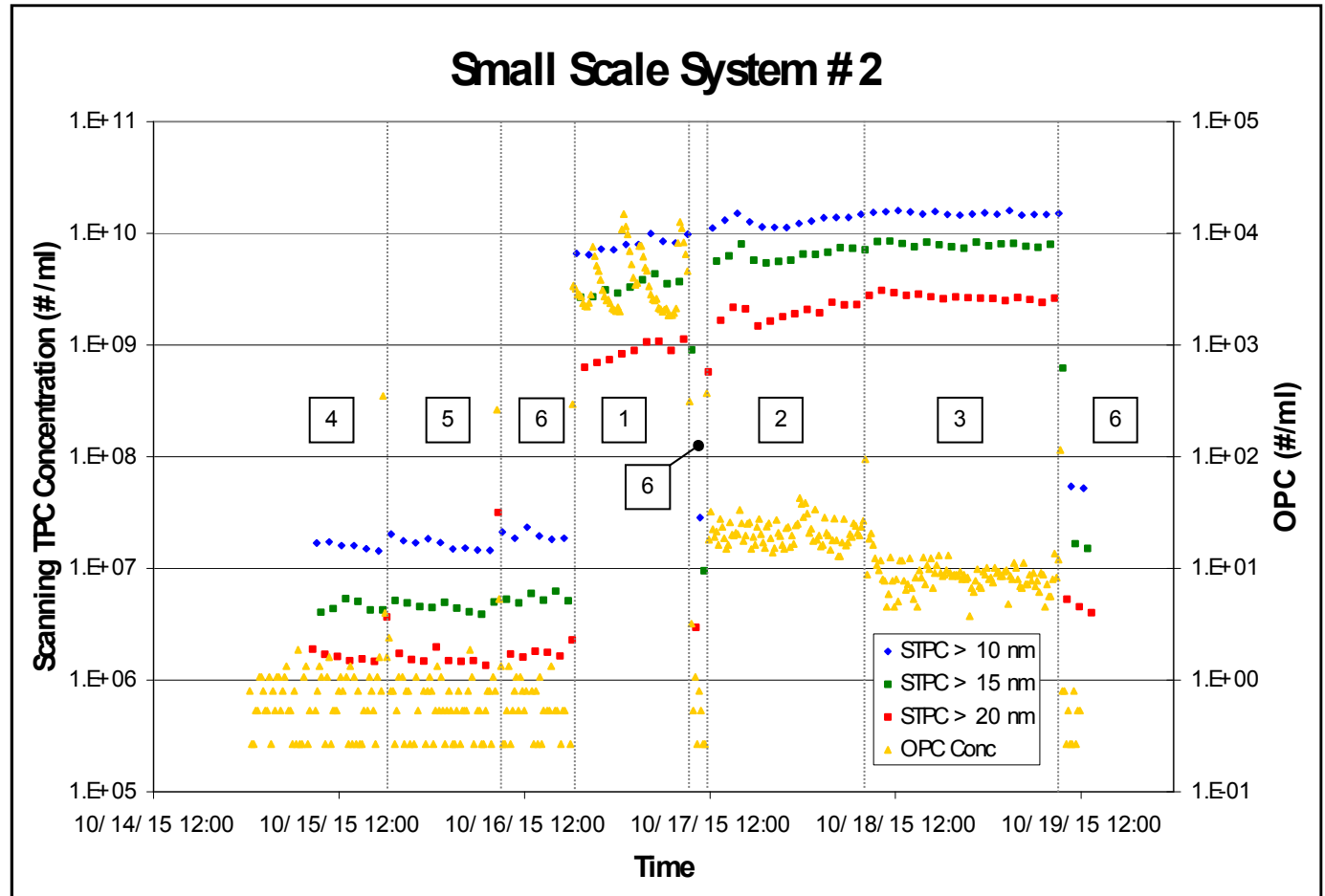
Small Scale System #1

- Particle removal by 10 nm rated membrane filter measured by ScanningTPC
- Port testing should be done upstream of the mixed bed ion exchange modules to optimize UF placement
 - Upstream of polish mixed bed ion-exchange may increase resin life

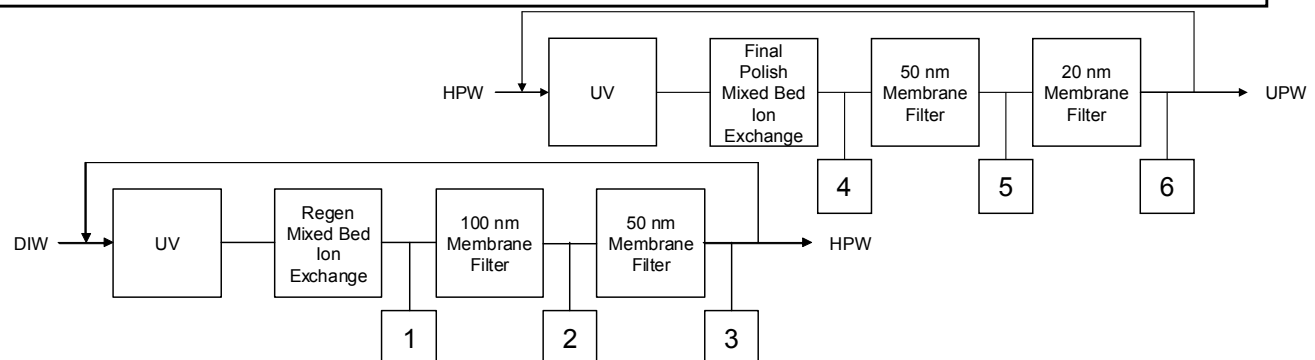
Scanning TPC and OPC Monitoring

Small Water System 2

- High particle concentration observed downstream of regenerated IX resin
- 100 and 50 nm filters on HPW loop do not show strong reduction in sub 50 nm particles
- LRV of > 50 nm particles out of HPW filter set #2 is 2.5 to 3.
- A significant portion of the sub 50 nm particles appear to be removed by the final polish ion exchange resin.



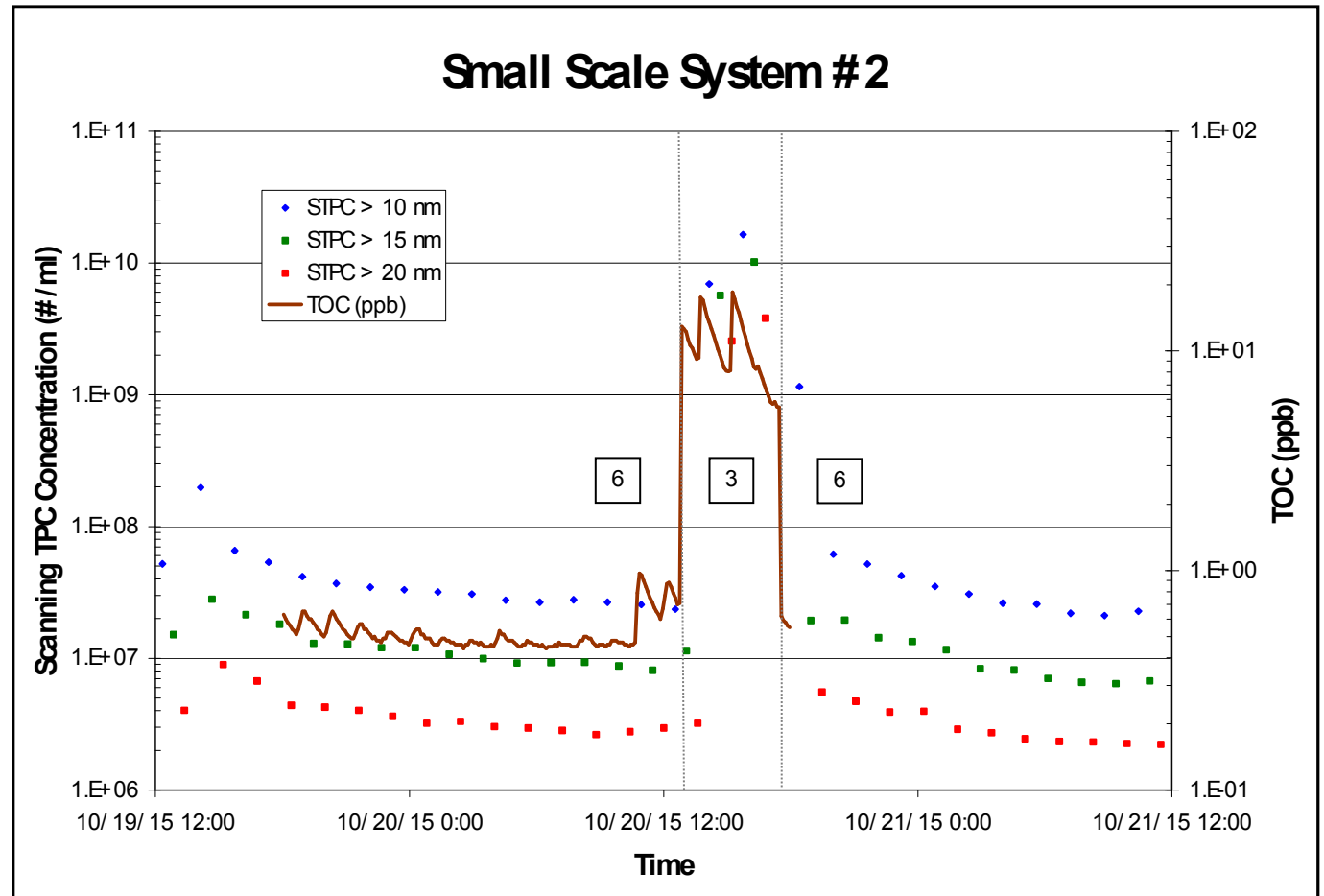
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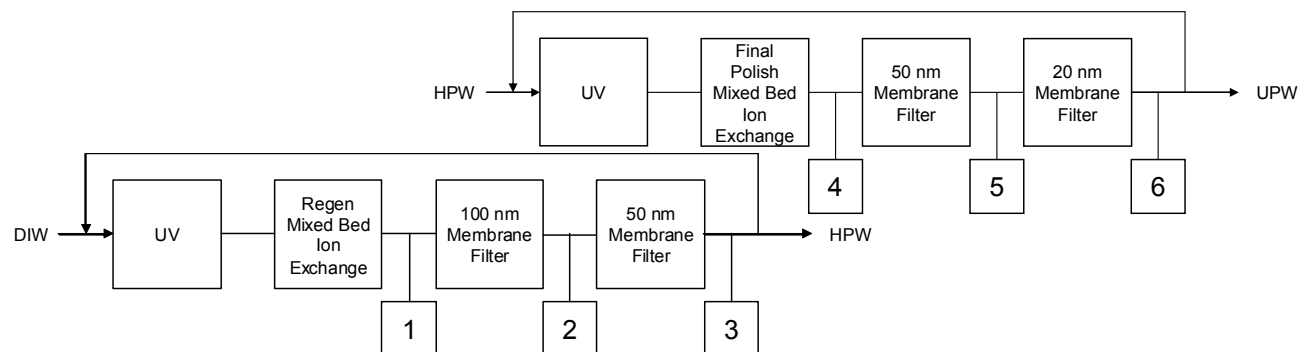
Scanning TPC and TOC Monitoring

Small Water System 2

- Large drop in TOC between HPW and UPW systems
- Unknown if HPW TOC is present as particles or as dissolved material



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What did we learn?

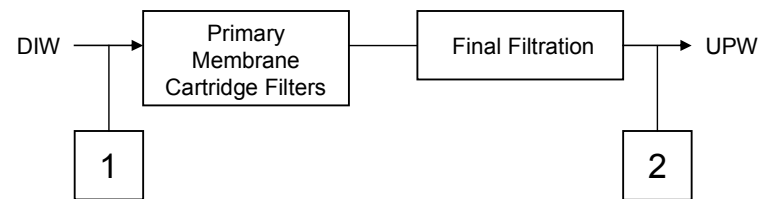
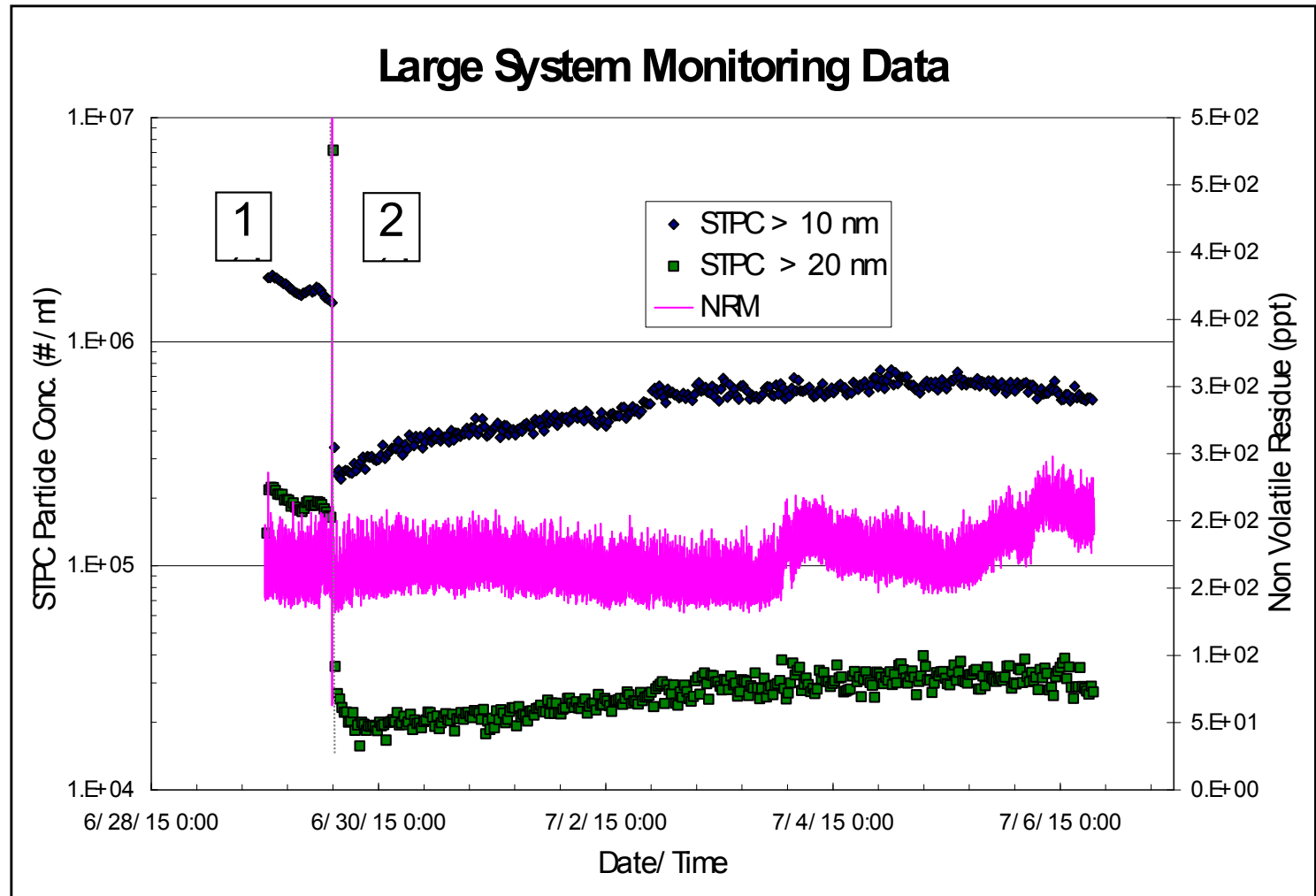
Small Scale System #2

- Final polish mixed bed ion-exchange module appears to have high particle retention capacity
- UF module with a high loading capacity between the HPW and UPW loops may increase component life, specifically the virgin mixed bed ion exchange resin.
 - Test multiple placement points
 - Particles may be coming from UPW recirculation pump
- Further port testing with TOC monitor will show sources and sinks
 - How much TOC does the regenerated mixed bed resin add
 - Test additional UV module downstream of virgin ion exchange resin

Scanning TPC and NRM Monitoring

Large Water System

- STPC sees a large reduction in counts whereas the NRM does not
- Other NVR features are seen which are not detected by STPC



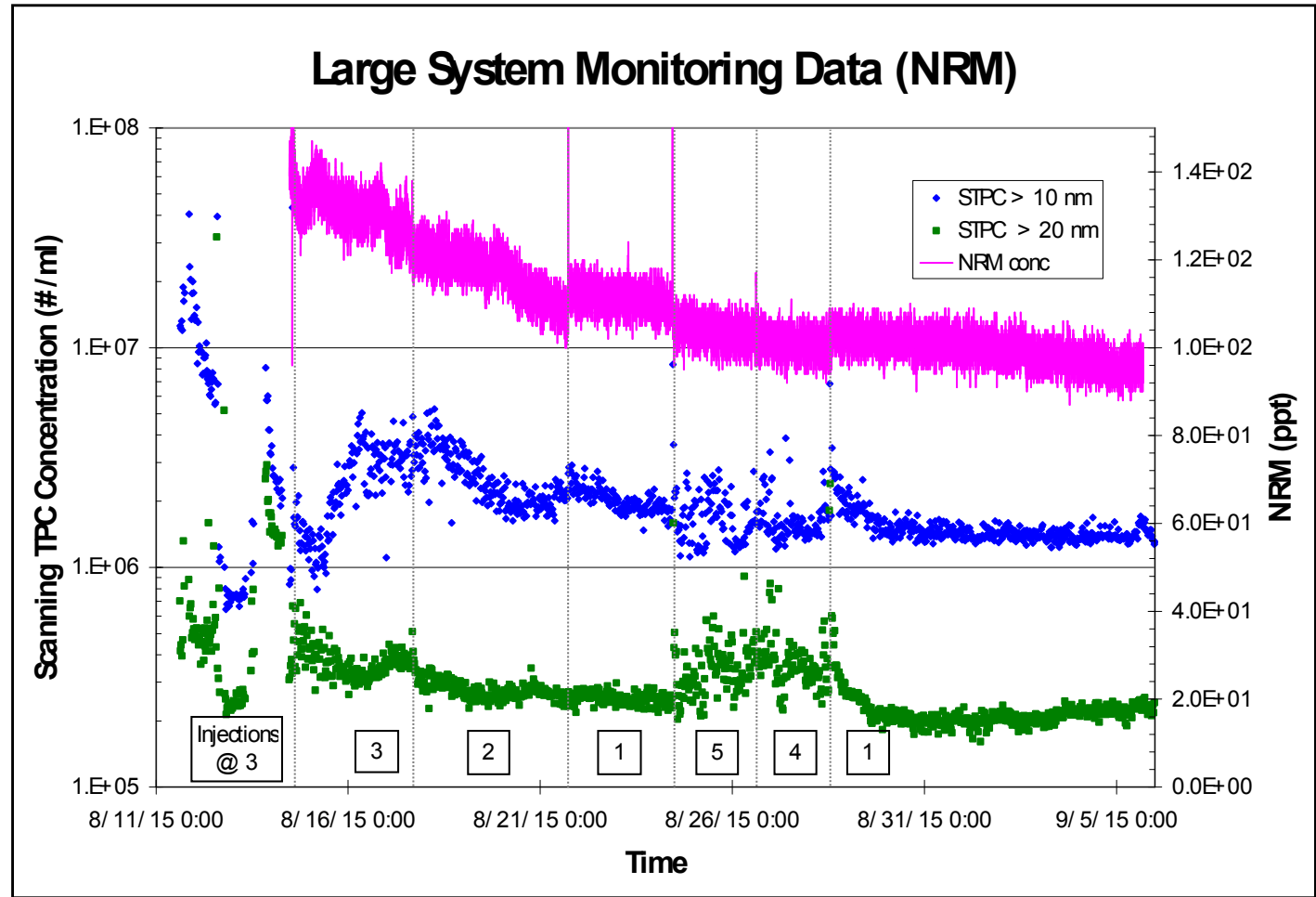
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Large Scale UPW System

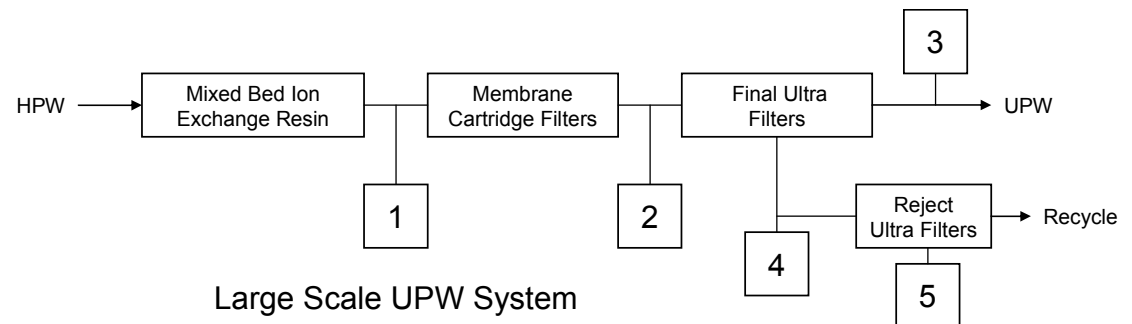
Scanning TPC and NRM Monitoring

Large Water System

- NRM shows slight bump on cartridge filter feed
- 10 nm particles appear on 8/16-8/19. Not seen by NRM or 20 nm STPC channel



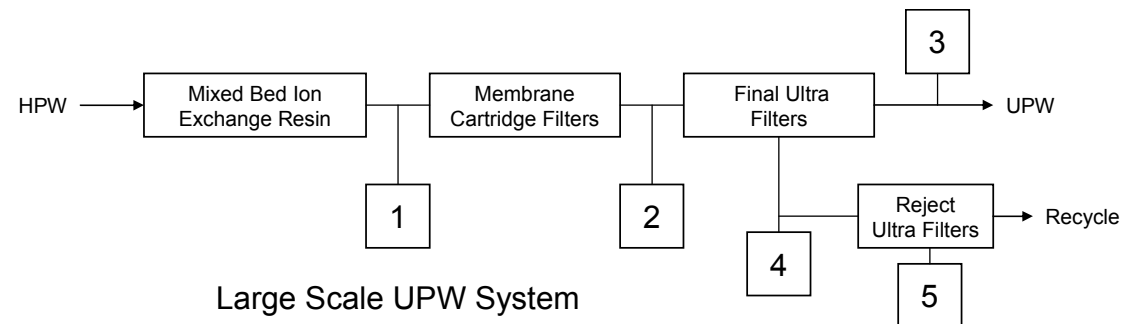
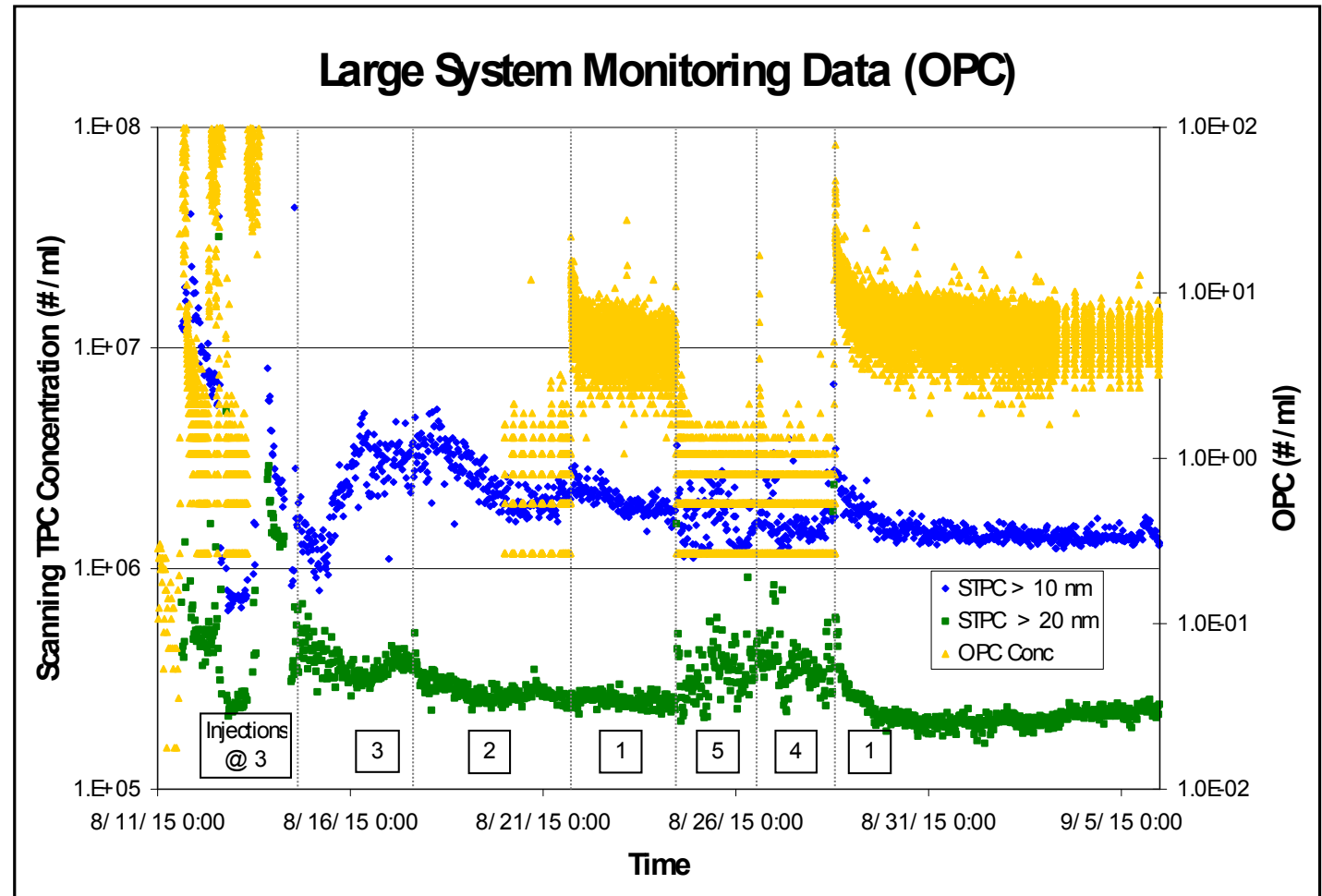
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Scanning TPC and OPC Monitoring

Large Water System

- OPC Detects change across final cartridge filter
- No difference for UF feed, product, or rejects

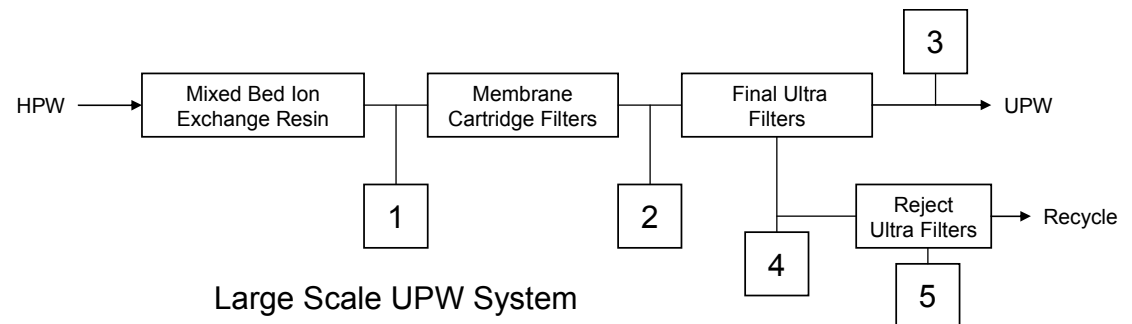
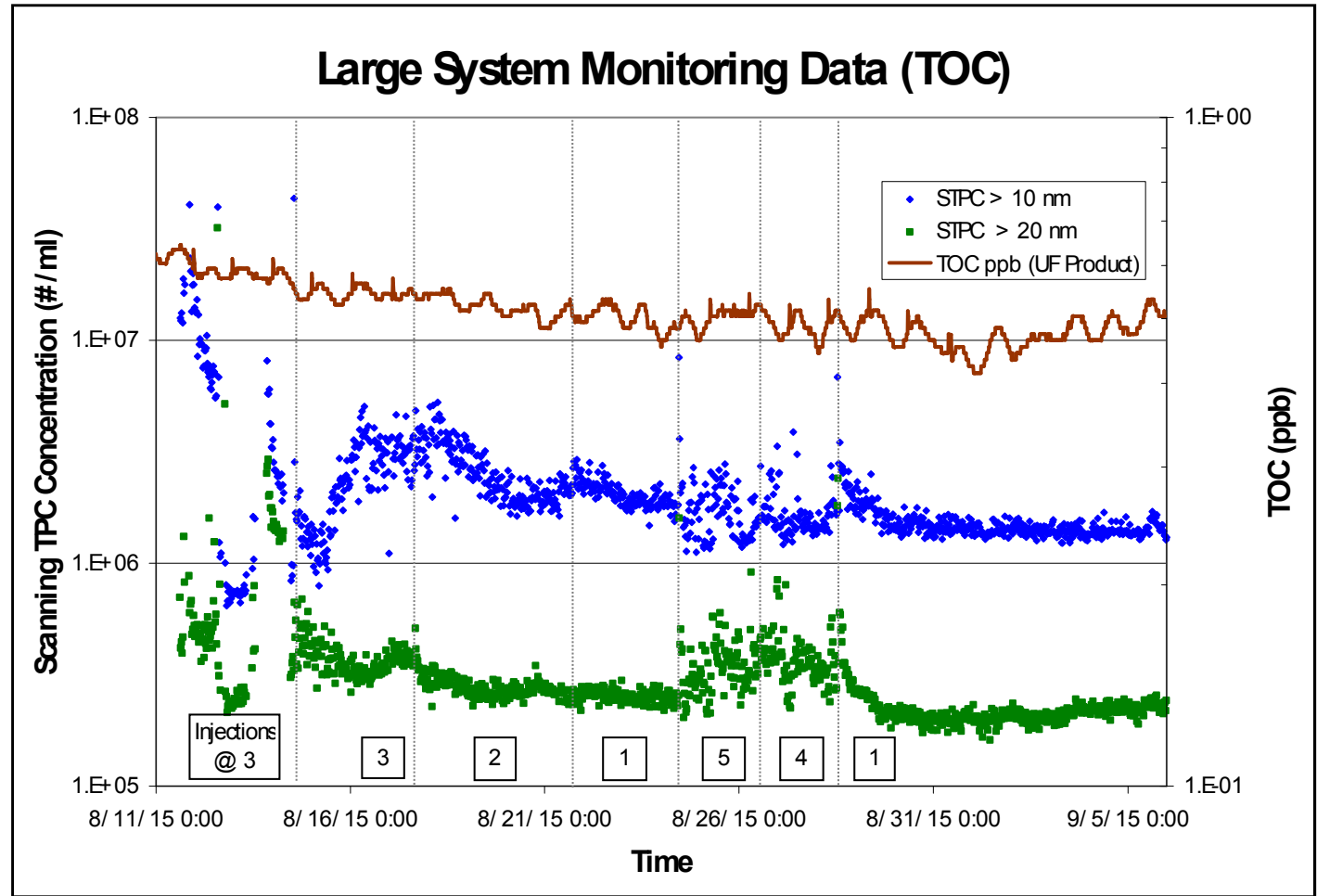


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Scanning TPC and TOC Monitoring

Large Water System

- TOC has daily cycles not seen by NRM or STPC
- 20 nm STPC channel tends to track the TOC level trend



What did we learn?

Large Scale System #1

- Sampling should be repeated with a TOC monitor in parallel
- OPC is effective at showing large, low concentration particle removal across cartridge filters in this system
- Testing should be done downstream of a high performance point of use filter
- Data indicate that the majority of particle removal is accomplished upstream of the final filtration modules

Conclusions

- Scanning TPC and Non-Volatile Residue monitoring are able to distinguish sources of contamination in UPW
- Ensemble of instruments is useful for design and monitoring of UPW systems

The Takeaway

TOC, NRM, and ScanningTPC measurements provide different information for the UPW system engineer. Used together, these instruments aid in UPW system design and maintenance

Thank you

Questions?

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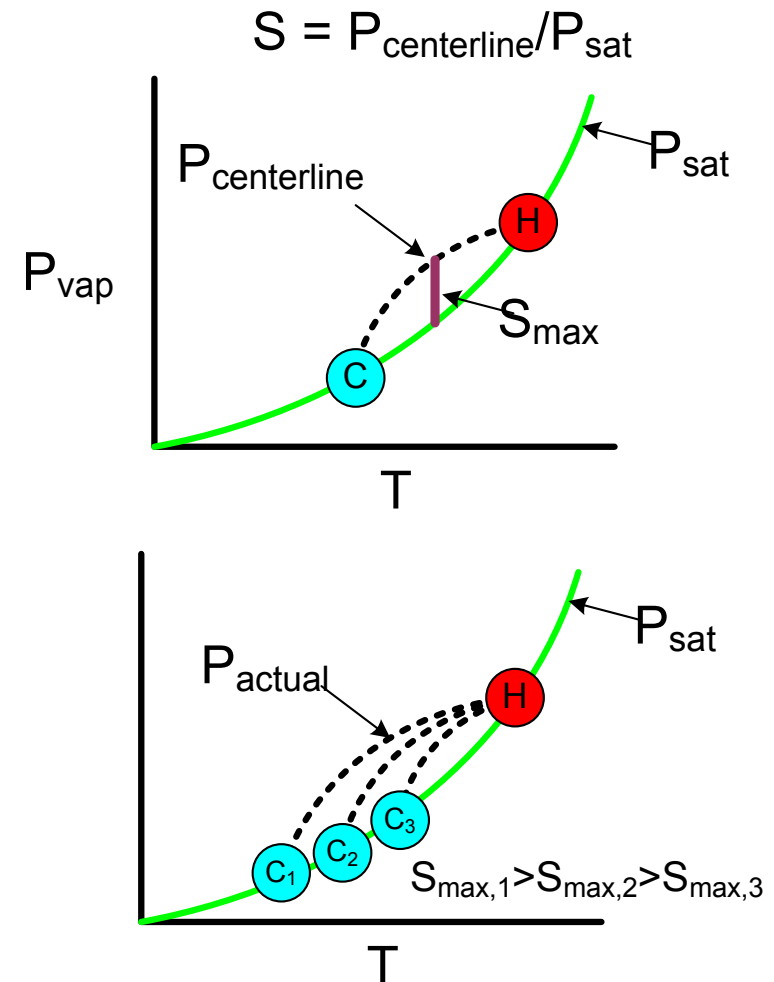
Patents US 8,272,253; US 8,573,034; US 7,852,465; Other patents pending

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Scanning Threshold Particle Counter (ScanningTPC)

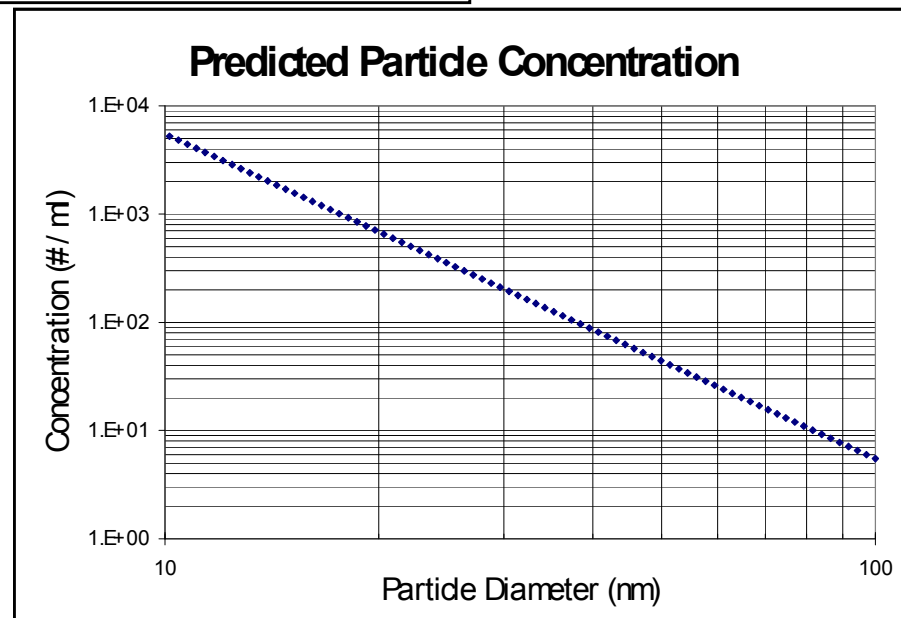
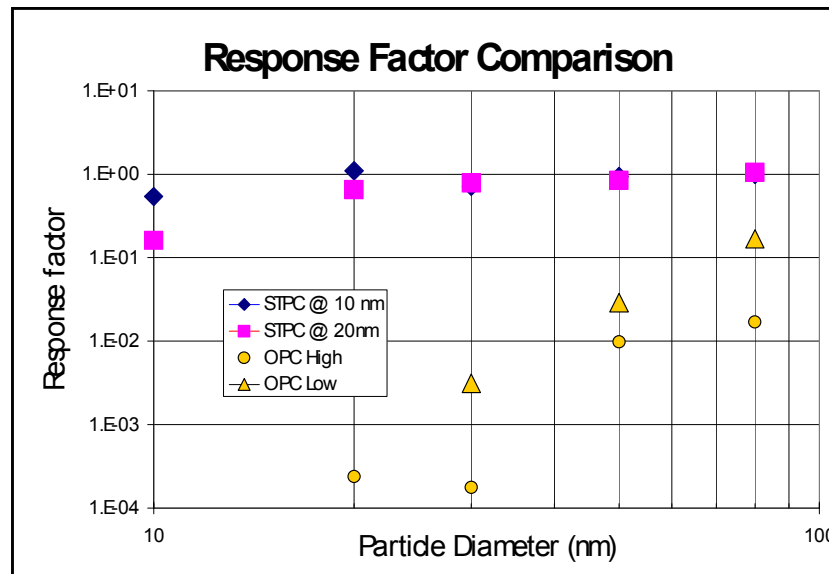
- Condensation Aerosol-Particle Counter detects particles larger than a threshold size
- Threshold size is a function of the saturation ratio, S of the condensing vapor
- S is varied by changing CPC operating temperatures



Scanning NTC and Optical Counter Comparison

Detection Efficiency

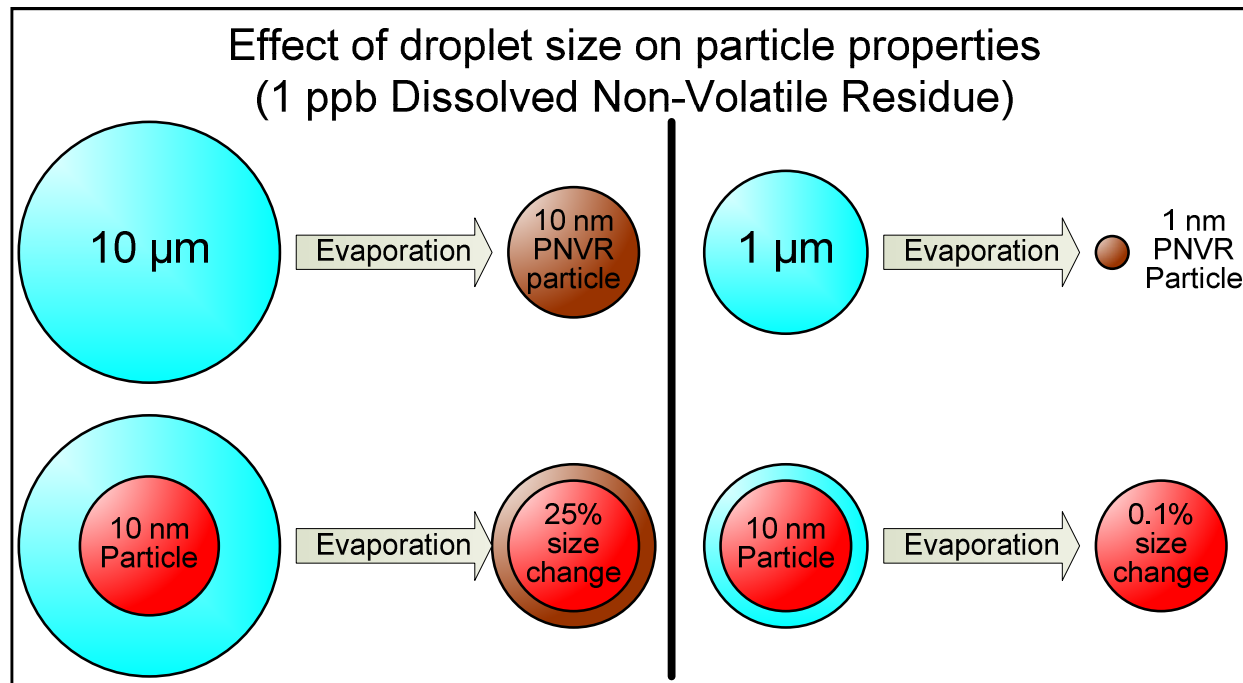
- OPC has difficulty detecting < 50 nm colloidal silica
- Low OPC background counts leads to high sensitivity for > 50 nm particles
- Background concentration at 10 and 20 nm is likely several orders of magnitude higher than reported by OPC at 50 nm



- 20 #/ml @ 65nm (corrected for OPC detection efficiency)
- -3 log-log slope

Droplet size and Non-Volatile Residue

- Size of particle composed of Precipitated Non-Volatile Residue (PNVR) is proportional to its parent droplet size
- Interference of solid particle properties by PNVR is controlled by limiting the size of large droplets and operating on systems with low levels of Dissolved NVR (<500 ppt)

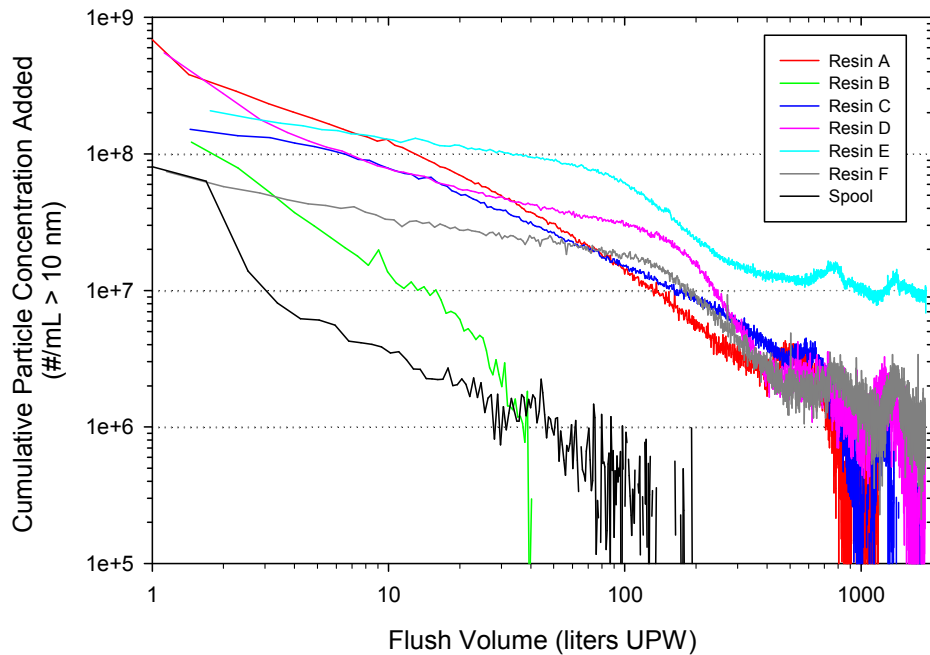


ScanningTPC and NRM Monitoring

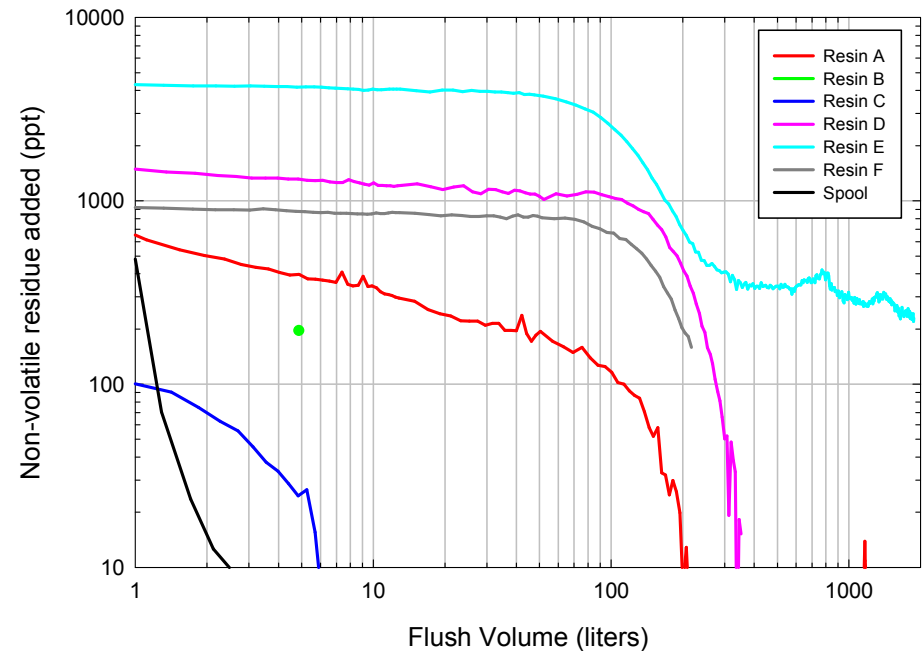
Resin rinse

- NVR composition during resin rinse varies by manufacturer

Particle Rinse



Non-volatile Residue Rinse



Data prepared and presented by CT Associates to the SEMI Ion Exchange Task Force on 02/27/2014